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PATENT  
Attorney Docket No. 7363.0010

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Reissue Application of: )

U.S. Patent No.: 5,792,261 )

Inventor: Kiichi HAMA et al. )

Issued: August 11, 1998 )

Serial No.: 09/478,370 )

Filed: January 6, 2000 )

For: PLASMA PROCESS  
APPARATUS )

Group Art Unit: 1763

Examiner: Alejandro Mulero, L.

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Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

**PETITION FOR EXTENSION OF TIME**

Applicants hereby petition for a three-month extension of time to respond to the Office Action of March 27, 2001. A fee of \$890.00 is enclosed herewith.

If there are any other fees due in connection with the filing of this response, please charge the fees to our Deposit Account No. 06-0916. If a fee is required for an extension of time under 37 C.F.R. § 1.136 not accounted for above, such an extension is requested and the fee should also be charged to our Deposit Account.

Respectfully submitted,

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890.00 DP

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Dated: September 6, 2001

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